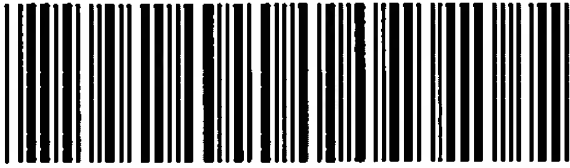


<div>Search Notes</div> <div></div>	Application/Control No.	Applicant(s)/Patent under Reexamination	
	10/659,213	MIYA ET AL.	
	Examiner	Art Unit	
	Jason Heckert	1746	JMH

SEARCHED			
Class	Subclass	Date	Examiner
134	99, 157, 155, 902, 153, 61, 64	8/14/2006	JMH
134	95.2,95.3	8/14/2006	JMH
134	94.3	8/14/2006	JMH
118	52,54	8/14/2006	JMH
156	345	8/14/2006	JMH

INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner

SEARCH NOTES (INCLUDING SEARCH STRATEGY)		
	DATE	EXMR
Consulted with Michael Barr	8/14/2006	JMH
Consulted With Joseph Perrin	8/15/2006	JMH
Consulted with Alexander Markoff	8/15/2006	JMH
Searched East		